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Please find below and/or attached an Office communication concerning this application or proceeding.

,	Application No.	Applicant(s)					
•	10/039,615	WALLACE, ROBERT F.					
Office Action Summary	Examiner	Art Unit					
	Quang D Vu	2811					
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the c	correspondence address					
A SHORTENED STATUTORY PERIOD FOR REPL THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a repl - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statute - Any reply received by the Office later than three months after the mailin earned patent term adjustment. See 37 CFR 1.704(b). Status	136(a). In no event, however, may a reply be tingly within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).					
1) Responsive to communication(s) filed on <u>am</u>	endment filed on 03/25/03 .						
2a) This action is FINAL . 2b) ⊠ Th	nis action is non-final.						
3) Since this application is in condition for allow closed in accordance with the practice under							
Disposition of Claims							
4)⊠ Claim(s) <u>1-19</u> is/are pending in the application							
4a) Of the above claim(s) is/are withdra	wn from consideration.						
	5) Claim(s) is/are allowed.						
	☑ Claim(s) <u>1-19</u> is/are rejected.						
7) Claim(s) is/are objected to.							
8) Claim(s) are subject to restriction and/o	or election requirement.						
9) The specification is objected to by the Examine	⊃r						
10) The drawing(s) filed on is/are: a) acce		iminer.					
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). 11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.							
If approved, corrected drawings are required in reply to this Office action.							
12) The oath or declaration is objected to by the Examiner.							
Priority under 35 U.S.C. §§ 119 and 120		•					
13) Acknowledgment is made of a claim for foreig	n priority under 35 U.S.C. § 119(a	a)-(d) or (f).					
a) ☐ All b) ☐ Some * c) ☐ None of:							
1. Certified copies of the priority documents have been received.							
2. Certified copies of the priority documen	ts have been received in Applicat	ion No					
 3. Copies of the certified copies of the price application from the International Both See the attached detailed Office action for a list 	ureau (PCT Rule 17.2(a)).						
14) Acknowledgment is made of a claim for domes	tic priority under 35 U.S.C. § 119((e) (to a provisional application).					
a) ☐ The translation of the foreign language pr 15)☐ Acknowledgment is made of a claim for domes	• •						
Attachment(s)							
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s)	5) 🔲 Notice of Informal	ry (PTO-413) Paper No(s) Patent Application (PTO-152)					



Application No.

Art Unit: 2811

DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

2. Claims 16 and 19 are rejected under 35 U.S.C. 102(e) as being anticipated by US Patent No. 6,399,421 to Han et al.

Regarding claim 16, Han et al. (figure 3) teach a molded semiconductor device package comprising:

a die attach pad (59);

a first (42) and a second (50) semiconductor die, each die having a die bond pad (48, 58), each of the die positioned such that the die bond pads of each die face in opposite directions, the first (42) and second (50) die being connected to opposing surfaces of the die attach pad (59);

a contact lead (62) positioned proximate to the first (42) and second (50) die;

a first gold bonding wire (40) that is stitch bonded to the contact lead (62) and stitch bonded to the die bond pad (48) of the first die (42), wherein the first gold bonding wire (40) was stitch bonded to the contact lead (62) after being stitch bonded to the die bond pad (48);

Art Unit: 2811

a second gold bonding wire (40) that is stitch bonded to the contact lead (62) and stitch bonded to the die bond pad (58) of the second (50) die, wherein the second gold bonding wire (40) was stitch bonded to the contact lead (62) after being stitch bonded to the die bond pad (58); and

a molding cap (66) that encapsulated the first (42) and second (50) die, the first and second bonding wire (40), and a portion of the contact lead (62).

The claim limitations "the first aluminum bonding wire was stitch bonded to the contact lead before being stitch bonded to the die bond pad and the second aluminum bonding wire was stitch bonded to the contact lead before being stitch bonded to the die bond pad" in claim 16 are taken to be product by process limitations which do not carry weight in claim drawn to structure. A product by process claim directed to the product per se, no matter how actually made, In re Hirao, 190 USPQ 15 at 17 (footnote 3). See In re Fessman, 180 USPQ 324, 326 (CCPA 1974); In re Marosi et al., 218 USPQ 289, 292 (Fed. Cir. 1983); and particularly In re Thorpe, 277 USPQ 964, 966 (Fed. Cir. 1985), all of which make it clear that it is the patentability of the final structure of the product "gleaned" from the process steps, which must be determined in a "product by process" claim, and not the patentability of the process. See also MPEP 2113.

Moreover, an old and obvious product produced by a new method is not a patentable product, whether claimed in "product by process" claims or not.

Regarding claim 19, Han et al. teach the first die contains integrated circuit components configured to form a memory or a logic unit (column 1, lines 26-29).

Application/Control Number: 10/039,615 Page 4

Art Unit: 2811

Claim Rejections - 35 USC § 103

3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims 1, 4 and 5 are rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent No. 6,399,421 to Han et al.

Regarding claim 1, Han et al. (figure 3) teach a molded semiconductor device package comprising:

a die attach pad (59);

a first (42) and second (50) semiconductor die, each die having a die bond pad (48, 58), each of the die positioned such that the die bond pads (48, 58) of each die face in opposite directions, the first (42) and second (50) die being connected to opposing surfaces of the die attach pad (59);

a contact lead (62) positioned proximate to the first (42) and second (50) die;

a first bonding wire (40) that is stitch bonded to the die bond pad (48) of the first die (42);

a second bonding wire (40) that is stitch bonded to the die bond pad (58) of the second die (50); and

a molding cap (66) that encapsulates the first (42) and second (50) die, the first and second bonding wire (40), and a portion of the contact lead (62).

Art Unit: 2811

Han et al. differ from the claimed invention by not showing the molding cap has a thickness of less than about 1 millimeter. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the molding cap has a thickness of less than about 1 millimeter, since it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art. In re Boesch, 617 F.2d 272, 205 USPQ 215 (CCPA 1980).

Regarding claim 4, Han et al. teach the first bonding wire (40) is also stitch bonded to the contact lead (62) and the second bonding wire (40) is also stitch bonded to the contact lead (62).

Regarding claim 5, Han et al. teach the first and second bonding wire (40) are formed of a material selected form gold (column 4, lines 41-42).

5. Claim 2 is rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent No. 6,399,421 to Han et al. as applied to claim 1 above, and further in view of US Patent No. 5,735,030 to Orcutt.

Regarding claim 2, Han et al. differ from the claimed invention by not showing a first conductive ball formation that is formed between the first bonding wire and the die bond pad of the first die; and a second conductive ball formation that is formed between the second bonding wire and the die bond pad of the second die. However, Orcutt (figure 3) teaches a conductive ball formation (21) that is formed between the bonding wire (1) and the die bond pad (5) of the die (7). It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate a

Application/Control Number: 10/039,615 Page 6

Art Unit: 2811

conductive ball formation that is formed between the bonding wire and the die bond pad of the die of Orcutt into the device taught by Han et al. because it is desirable to hold the wire securely on the chip. The combined device shows a first conductive ball formation that is formed between the first bonding wire and the die bond pad of the first die; and a second conductive ball formation that is formed between the second bonding wire and the die bond pad of the second die.

6. Claim 3 is rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent No. 6,399,421 to Han et al. as applied to claim 1 above, and further in view of US Patent No. 5,735,030 to Orcutt.

Regarding claim 3, Han et al. differ from the claimed invention by not showing the first bonding wire is also ball bonded to the contact lead and the second bonding wire is also ball bonded to the contact lead. However, Orcutt (figure 3) teaches the bonding wire (1) is ball bonded to the contact lead (9). It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the ball bonded bonding wire to the contact lead of Orcutt into the device taught by Han et al. because it is desirable to hold the wire securely on the chip. The combined device shows the first bonding wire is also ball bonded to the contact lead and the second bonding wire is also ball bonded to the contact lead.

Page 7

Application/Control Number: 10/039,615

Art Unit: 2811

7. Claims 7, 9, 10 and 11 are rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent No. 6,399,421 to Han et al. in view of US Patent No. 5,735,030 to Orcutt.

Regarding claim 7, Han et al. (figure 3) teach a molded semiconductor device package comprising:

a die attach pad (59);

a first (42) and a second (50) semiconductor die, each die having a die bond pad (48, 58), each of the die (42, 50) positioned such that the die bonds (48, 58) of each die face in opposite directions, the first (42) and second (50) die being connected to opposing surface of the die attach pad (59);

a contact lead (62) positioned proximate to the first (42) and second (50) die;

a first bonding wire (40) that is stitch bonded to the die bond pad (48) of the first die (42);

a second bonding wire (40) that is stitch bonded to the die bond pad (58) of the second die (50); and

a molding cap (66) that encapsulates the first (42) and second (50) die, the first and second bonding wire (40), and a portion of the contact lead (62).

Han et al. differ from the claimed invention by not showing a first bonding wire that is ball bonded to the contact lead; and a second bonding wire that is ball bonded to the contact lead. However, Orcutt (figure 3) teaches the bonding wire (1) is also ball bonded to the contact lead (9). It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the ball bonded bonding

Art Unit: 2811

wire of Orcutt into the device taught by Han et al. because it is desirable to hold the wire securely on the chip. The combined device shows a first bonding wire that is ball bonded to the contact lead and a second bonding wire that is ball bonded to the contact lead.

Regarding claim 9, Han et al. teach the first and second bonding wire (40) are formed of a material selected form gold (column 4, lines 41-42).

Regarding claim 10, Han et al. differ from the claimed invention by not showing the molding cap has a thickness of less than about 1 millimeter. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the molding cap has a thickness of less than about 1 millimeter, since it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art. In re Boesch, 617 F.2d 272, 205 USPQ 215 (CCPA 1980).

Regarding claim 11, Han et al. teach the first die contains integrated circuit components configured to form a memory or a logic unit (column 1, lines 26-29).

8. Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent No. 6,399,421 to Han et al. as applied to claim 1 above, and further in view of US Patent No. 6,437,429 to Su et al.

Regarding claim 6, Han et al. differ from the claimed invention by not showing the package is either a thin small outline package or a quad flat pack package.

However, Su et al. teach the package is a thin small outline package or a quad flat pack package (column 1, lines 13-20). Therefore, it would have been obvious to one having

ordinary skill in the art at the time the invention was made to incorporate the teaching of Su et al. into the device taught by Han et al., since it is a conventional semiconductor device package.

9. Claim 8 is rejected under 35 U.S.C. 103(a) as being unpatentable over Han et al. and Orcutt as applied to claim 7 above, and further in view of US Patent No. 6,437,429 to Su et al.

Regarding claim 8, Han et al. and Orcutt differ from the claimed invention by not showing the package is either a thin small outline package or a qua flat pack package. However, Su et al. teach the package is a thin small outline package or a quad flat pack package (column 1, lines 13-20). Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teaching of Su et al. into the device taught by Han et al. and Orcutt, since it is a conventional semiconductor device package.

10. Claims 12-15 are rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent 6,399,421 to Han et al. and US Patent No. 5,735,030 to Orcutt.

Regarding claim 12, Han et al. (figure 3) teach a molded semiconductor device package comprising:

a pair of semiconductor dice (42, 50) that are oriented such that a top surface of each die are facing in opposite directions, the top surface of each die having at least one die bond pad (48, 58);

Art Unit: 2811

at least one contact lead (62) positioned proximate to the pair of semiconductor dice (42, 50);

a molding cap (66) that encapsulated the pair of semiconductor dice (42, 50), the bonding wire (40) and a portion of the contact lead (62).

Han et al. differ from the claimed invention by not showing a conductive ball formation positioned on the die bond pad and at least one bonding wire that is ball bonded to the contact lead and stitch bonded to the conductive ball formation.

However, Orcutt (figure 3) teaches a conductive ball (21) formation that is formed on the die pad (5) and the bonding wire (1) is also ball bonded to the contact lead (9) and stitch bonded to the conductive ball formation (21). It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate a conductive ball formation that is formed on the die pad and the ball bonded bonding wire to the contact lead and stitch bonded to the conductive ball formation of Orcutt into the device taught by Han et al. because it is desirable to hold the wire securely on the chip and the lead.

Regarding claim 13, Han et al. teach a die attach pad (59) that is attached to and sandwiched between the pair of semiconductor dice (42, 50).

Regarding claim 14, Han et al. teach the bonding wire (40) is gold. (column 4, lines 41-42).

Regarding claim 15, Han et al. differ from the claimed invention by not showing the molding cap has a thickness of less than about 1 millimeter. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the

molding cap has a thickness of less than about 1 millimeter, since it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art. In re Boesch, 617 F.2d 272, 205 USPQ 215 (CCPA 1980).

11. Claim 18 is rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent 6,399,421 to Han et al.

Regarding claim 18, Han et al. differ from the claimed invention by not showing the molding cap has a thickness of less than about 1 millimeter. It would have been obvious to one having ordinary skill in the art at the time the invention was made for the molding cap has a thickness of less than about 1 millimeter, since it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art. In re Boesch, 617 F.2d 272, 205 USPQ 215 (CCPA 1980).

12. Claim 17 is rejected under 35 U.S.C. 103(a) as being unpatentable over US Patent No. 6,399,421 to Han et al. as applied to claim 16 above, and further in view of US Patent No. 6,437,429 to Su et al.

Regarding claim 17, Han et al. differ from the claimed invention by not showing the package is either a thin small outline package or a quad flat pack package.

However, Su et al. teach the package is a thin small outline package or a quad flat pack package (column 1, lines 13-20). Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teaching of

Su et al. into the device taught by Han et al., since it is a conventional semiconductor device package.

Response to Arguments

Applicant's arguments filed 03/25/03 have been fully considered but they are not persuasive.

It is argued, in page 2 of the remarks, that Han et al. do not teach or suggest stitch bonding a bonding wire to the bond pad of a die. It is also urged that Han et al. do not teach the wires are "put on" in any specific manner. This argument is not convincing because Han et al. teach bonding wire (40) is bonded to the die bond pads (48, 58) of the first die (42) and the second die (50) without using any solder ball material.

Therefore, it is believed that the bonding wire (40) is stitch bonded to the die bond pads (48, 58).

It is argued, in page 3 of the remarks, that Han et al. do not teach or suggest the conductive ball formation. This argument is not convincing because the combined device of Han et al. and Orcutt teach the conductive ball formation positioned on the die bond pad and the bonding wire that is ball bonded to the contact lead and stitch bonded to the conductive ball formation. It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate a conductive ball formation that is formed on the die pad of Orcutt into the device taught by Han et al. because it is desirable to hold the wire securely on the chip and minimize the damage to the wire (column 2, lines 20-27).

It is argued, in page 3 of the remarks, that Han et al. do not teach or suggest stitch bonding a wire to both a die and a contact lead. This argument is not convincing because Han et al. teach bonding wire (40) is stitch bonded to the die (42) and contact lead (62).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Quang D Vu whose telephone number is 703-305-3826. The examiner can normally be reached on Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas can be reached on 703-308-2772. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-7722 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

qv June 2, 2003 Steven Sake